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INFORMATION DISCLOSURE STATEMENT BY APPLICANT	APR 08 2004	Application Number: 10/646,467 Filing Date: August 22, 2003 First Named Inventor: Kenneth COLLINS, et al. Group Art Unit: Unknown 2812 Examiner Name: Unknown GS14KA Attorney Docket Number: 6915 P06
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Examiner's Signature: *Alain S. Harris*

Date Considered: *2/3/07*

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.